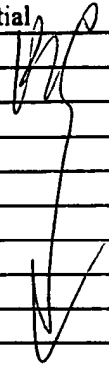


Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty. Docket No. HIT1P027 / HSI9-2003-0150US1	Application No.: Unassigned 10/717129
	Applicant: J. Mac Freitag et al.	Group Art Unit: Unassigned 1762
	Filing Date: Herewith	

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Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	A	2003/0035253	02/20/2003	Lin et al.	360	324	08/17/2001
	B	2002/0085320	07/04/2002	Gill	360	324.11	01/04/2001
	C	6,143,380	07/02/2002	Pinarbasi	204	192.11	08/14/2000
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							Yes	No
	M	11-144956	28.05.1999	Japan	H01F	10/16	X	
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	R	Lee, W. Y. et al., "Effects of Mn Concentration and Deposition Temperature on the Giant Magnetoresistive Properties of Ion-Beam-Deposited PtMn Spin Valves", IEE Transactions on Magnetics, Vol. 38, No. 5, September 2002 pp 3536-3539
	S	Sant, S. et al., "Giant Magnetoresistance in Ion Beam Deposited Spin-Valve Films with Specular Enhancement", Journal of Applied Physics, Volume 89, Number 11, June 1, 2001. pp 6931-6933
	T	
Examiner	Date Considered	

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.